IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SAKAMOTO et al.

Serial No.: 09/449,907

Filed: December 2, 1999

Group: 3723

Examiner D. Nguyen

For: POLISHING CLOTH FOR CHEMICAL MECHANICAL POLISHING, AND CHEMICAL MECHANICAL POLISHING APPARATUS USING SAID CLOTH

PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, D.C. 20231

December 18, 2000

Dear Sir:

Applicants petition the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated October 17, 2000, for one (1) month from November 17, 2000 to December 17, 2000.

A check in the amount of One Hundred Ten Dollars (\$110.00) to cover the cost of the extension is attached herewith. In the event that any additional fees are required with respect to this paper, please charge our Deposit Account No. 01-2300.

Respectfully submitted,

George E. Oram. Jr. Attorney for Applicant(s)

Registration No. 27,931

Arent/Fox Kintner Plotkin & Kal\n

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Atty. Docket No. 107176-09004

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GEO:sah